

Docket No. 2000-0086-1
USSN 09/716,041

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William N. Partlo, et al.

Serial No.: 09/716,041

Filed: November 17, 2000

For: HIGH POWER GAS DISCHARGE LASER
WITH HELIUM PURGED LINE
NARROWING UNIT

) Examiner: J. Nguyen

) Group Art Unit: 2815

BOX AF

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO FINAL OFFICE ACTION

Sir:

This letter is in response to Office Action mailed November 26, 2002.

REMARKS

The Examiner has rejected Applicants' claims based on an abandoned patent application ('374 Osamu) which was discredited by the authors' of the application. Applicants' requests reconsideration. The authors stated in a subsequent application that the technique referred to in the abandoned application would not work and "must be avoided". Under these circumstances the abandoned application is not a proper reference against Applicants' invention.